

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	Conf No.: 5397
David Thomas FORREST)	
)	Art Unit: 1794
Serial No. 10/581,622)	
)	Examiner: Ferguson, Lawrence D.
Filed: June 5, 2006)	
)	
For: FREE-STANDING SILICON CARBIDE)	
ARTICLES FORMED BY CHEMICAL)	
VAPOR DEPOSITION AND METHODS)	
FOR THEIR MANUFACTURE)	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The citation of information on the attached Form PTO/SB/08 is made pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98. A copy of each cited item is enclosed except for U.S. patents and U.S. patent application publications.

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I hereby certify that this correspondence is being electronically filed with The United States Patent Office via EFS Web on the date shown below.

/lisa norris/
Lisa Norris

June 17, 2009
Date

This paper is being filed pursuant to 37 C.F.R. §1.97(c), before the mailing of any of a final action under § 1.113, a notice of allowance under § 1.311, or an action that otherwise closes prosecution in the application.

The Commissioner is authorized to charge the fee set forth in § 1.17(p) to the firm's credit card for consideration of this paper. The Commissioner is authorized to charge any additional fee due to Deposit Account No. 11-0855.

Respectfully submitted,
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Date: June 17, 2009

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